

8525

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852517			
SERIAL NUMBER	FILING DATE	CLASS	SUBCLASS
		257	49
		437	40
		GROUP ART UNIT	EXAMINER
		2508-1104	SANDAT
			Frank

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\*\*CONTINUING DATA\*\*\*\*\*  
VERIFIED

none

\*\*FOREIGN/PCT APPLICATIONS\*\*\*\*\*  
VERIFIED

JED REC GERMANY

3-88799

03/18/91

JAPAN

foreign priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	AS FILED	STATE OR COUNTRY	SHEETS DRWGS.	TOTAL CLAIMS	INDEP. CLAIMS	FILING FEE RECEIVED	ATTORNEY'S DOCKET NO.
USC 119 conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no							
verified and Acknowledged	Examiner's Initials		JPX	6	20	5	\$964.30	0756-711

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SEMICONDUCTOR MATERIAL AND METHOD FOR FORMING THE SAME AND THIN FILM  
TRANSISTOR

U.S. DEPT. of COMM. Pat. &amp; TM Office - PTO-435L (rev. 10-78)

PARTS OF APPLICATION FILED SEPARATELY					
NOTICE OF ALLOWANCE MAILED		PREPARED FOR ISSUE		CLAIMS ALLOWED	
Amount Due		Assistant Examiner		Total Claims	
				Print Claim	
Date Paid		Docket Clerk		DRAWING	
Primary Examiner				Sheets Drwg.	
Label Area		ISSUE CLASSIFICATION		ISSUE BATCH NUMBER	
		Class			
		Subclass			
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